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# Growth of SiO<sub>x</sub> nanowire bunches cocatalyzed with Ga and Ni

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 $SiO_x$  nanowire bunches were fabricated on  $Ni(NO_3)_2^*6H_2O$  solution-coated Si(111) substrates in a chemical vapor deposition system in the presence of Ga and under the flow of Ar and  $NH_3$  gases. The roles of nickel nitrate hydrate, gallium, and ammonia in the formation of  $SiO_x$  nanowire bunches were investigated. It was found that Ni and Ga act as catalysts for the growth, while nickel nitrate hydrate also serves as a source of oxygen. The growth mechanisms of different nanowire structures obtained by varying the fabrication conditions are discussed. © 2005 American Institute of Physics. [DOI: 10.1063/1.2081114]

#### I. INTRODUCTION

SiO<sub>r</sub> nanowires may act as waveguides and be used as sensors with a higher sensitivity than the conventional optical fibers. Amorphous SiO<sub>x</sub> nanowires also show stable blue light emission,<sup>2</sup> which might have potential applications in, for example, integrated optical devices and high-resolution optical heads for scanning near-field optical microscopes.<sup>3</sup> Over the past few years, some researches have already been carried out on SiO<sub>x</sub> nanowire growth. Sun et al.<sup>4</sup> used Sn as the catalyst and obtained jellyfishlike and cherrylike SiOx nanowire structures. Pan and co-workers<sup>5–7</sup> used molten Ga decomposed from GaN powder as the catalyst and obtained five different SiO<sub>x</sub> nanowire structures including fishbonelike, gourdlike, and octopuslike structures. Zhu et al. 8 heated SiC/Co powder and obtained SiO<sub>x</sub> nanoflowers and observed nanowire loops. Wang et al.<sup>3</sup> obtained SiO<sub>x</sub> nanowire arrays as the by-product during growth of GaN nanostructures with In (decomposed from In<sub>2</sub>O<sub>3</sub>) as the catalyst. SiO<sub>x</sub> nanowires have also been fabricated with Fe (Refs. 2, 9, and 10) and Au (Ref. 11) as the catalysts, while some other morphological features such as nanosprings, <sup>10</sup> treelike, or tadpolelike nanowires <sup>12</sup> were all reported.

These interesting structures demonstrate the complexity of  $SiO_x$  growth. For example, from a single droplet of the catalyst, a bunch of  $SiO_x$  nanowires may be grown.  $SiO_x$  nanowires are amorphous. One wire may split up while many nanowires may branch together forming several nanowire bundles. Many of such features are unique to  $SiO_x$ , which are seldom observed in the growth of other nanomaterials. Therefore, it is of great fundamental interest as well as of application relevance to examine the structural and chemical contents of the  $SiO_x$  nanowires grown under various conditions. In this paper, we report the fabrication of  $SiO_x$  nanowires by using two metallic elements Ga and  $SiO_x$  nanowires by using two metallic elements  $SiO_x$  are observed, whose formation mechanism will be discussed.

#### **II. EXPERIMENT**

One-side-polished Si(111) substrates were ultrasonicated sequentially in toluene, acetone, ethanol, and deionized wa-

ter.  ${\rm Ni(NO_3)}_2^* 6{\rm H_2O}$  solution with a concentration of 5.5  $\times$  10<sup>-3</sup>M was then deposited onto the unpolished side of the Si substrate and then dried at 110 °C. Gallium was placed in the middle of a quartz boat. The dried Si substrates were placed 2 mm downstream from the Ga droplet. The quartz boat containing the Si substrates and Ga droplet was then inserted in a quartz tube to be heated in a tube furnace after being pumped to a pressure of  $3\times10^{-1}$  torr. The temperature of the furnace was then raised to 950 °C from room temperature at a ramping rate of 35 °C/min and then maintained at 950 °C for 30 min under the flow of Ar (99.999%) and NH<sub>3</sub> (99.999%) gases of different flow rates. Afterwards, the gas flow was cut off and the furnace was cooled naturally back to room temperature under vacuum.

Three different sets of conditions were used in this experiment as summarized in Table I. The grown samples were characterized by field-emission scanning electron microscopy (SEM, Leo1530) and transmission electron microscopy (TEM, JEOL 2010F). Both SEM and TEM were equipped with energy dispersive x-ray (EDX) facilities.

#### III. RESULTS AND DISCUSSION

The typical morphologies of the products formed on substrates under condition I are shown in Fig. 1. There are jellyfishlike nanowire bunches, nanowire spheres, and some isolated but randomly aligned nanowires on the substrates. The EDX spectra show that the randomly aligned nanowires are  $SiO_x$  with  $x \sim 1.6$  and the nanowire spheres are  $SiO_x$  with  $x \sim 2.6$ . The isolated randomly aligned  $SiO_x$  nanowires are over 20  $\mu$ m long with a diameter of around 30 nm. The diameters of the  $SiO_x$  nanowires forming the spheres are about

TABLE I. Three growth conditions used in our experiments.

	Ga (mg)	Ar (sccm) (standard cubic centimeter per minute)	NH <sub>3</sub> (sccm)	Growth pressure (torr)
Condition I	1045.5	100	50	3.1-3.2
Condition II	1041.0	100	100	5.3-5.6
Condition III	1059.1	50	100	4.2-4.4

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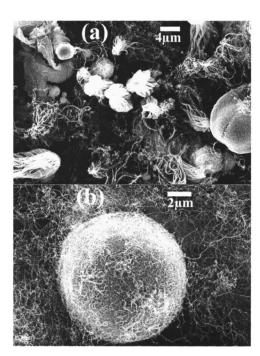


FIG. 1. SEM images of the samples grown with condition I with (a) showing the jellyfishlike nanowire bunches, and (b) showing one typical spherelike nanowire bunch.

30 nm. Similar SiO<sub>x</sub> nanowire spheres with the SiO<sub>x</sub> nanowire array forming the shells of the spheres were also observed by Wang et al.3

Several jellyfishlike nanowire bunches are shown in Fig. 2. From the images of Figs. 2(d) and 2(e), there appears a core inside the "head" of the jellyfish bunch, from which the nanowires started their growth. EDX measurements show that the heads of the jellyfishlike nanowire bunches contain Ni, Ga, Si, and O with the atomic percentages of 3, 6, 26, and 65, respectively, while the tails contain  $SiO_x$  with  $x \sim 2$ only. The lengths of the jellyfishlike nanowire bunches are around 20  $\mu$ m while the diameters are in the range of 12–64 nm. This morphology is different from those  $SiO_x$  nanowire bunches reported previously. <sup>4–7</sup> Here the nanowires grow not just from the lower hemisphere of the core but from the entire surface of the sphere. Another interesting phenomenon is the coalescence of the nanowires as shown in Fig. 2(f). SiO<sub>x</sub> nanowire loops formed by coalescence of two nanowires initiated from the same catalyst particles have also been reported.<sup>8</sup> Another observation is the nonuniform diameter of the nanowires in a bunch as revealed in Figs. 2(c) and 2(e). Generally the roots of the nanowires are thicker than the tops, agreeing with that of Meng et al., 13 but being different from that obtained by Pan and co-workers.<sup>5-7</sup>

Under condition II, several morphologies emerged as presented in Fig. 3. The first type shown in Figs. 3(a) and 3(b) can be characterized by growth of several nanowires from one single particle similar to that of Refs. 5-8. The particle shape is irregular, possibly due to the presence of the two catalysts (Ni and Ga). EDX data show that the particle is composed of Ni, Ga, Si, and O with the atomic percentages of 4, 9, 37, and 50, respectively, while the nanowires are  $SiO_r$ , with  $x \sim 1.2$ .

The second morphology as shown in Figs. 3(c) and 3(d)

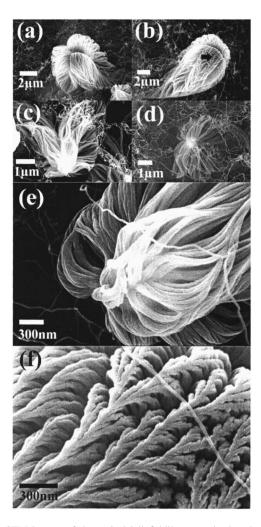


FIG. 2. SEM images of the typical jellyfishlike nanowire bunches grown with condition I, [(a)–(d)] Showing different jellyfishlike nanowire bunches. (e) Higher-resolution image of the head of a jellyfishlike nanowire bunch. A core and nanowires with nonuniform diameters can be observed. (f) Higherresolution image of the arrowed area shown in (b). Nanowire coalescence can be observed.

is Chinese lanternlike, where a nanowire bundle splits into a few smaller bundles but then rejoins, into one or fewer bundles. A similar structure has also been observed in a previous report.<sup>14</sup> Here from Fig. 3(d), it can also be observed that on one side of the Chinese-lanternlike nanowire bundles, the nanowires tangle and form a ropelike structure.

The typical morphology obtained under condition III is shown in Fig. 4. Two typical octopuslike nanowire bunches are observed, one without spots on the "octopus legs" [Fig. 4(a) and 4(b)], while the other with spots [Fig. 4(c)]. The heads of the octopuslike bunches are of irregular shape. The diameters of the nanowires forming the legs of the octopuslike bunches are not quite the same, unlike that in Refs. 6 and 7. EDX measurements show that the octopus "heads" contain Ni, Ga, Si, and O with the atomic percentage of 1, 4, 64, and 16, respectively, while the legs contain  $SiO_x$ , x $\sim$  0.1. Both the head and the tail are highly Si rich.

TEM results of the samples grown under condition I are presented in Fig. 5. From Figs. 5(a) and 5(b), it can be seen that some nanowires have a core/shell structure and in most cases the core is not as long as the wire. High-resolution

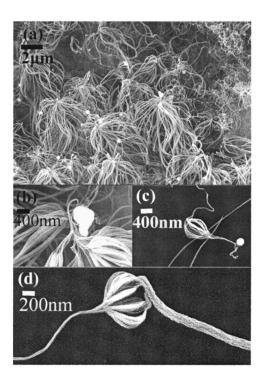


FIG. 3. Typical SEM images of the  $SiO_x$  nanowire bunches obtained with condition II. (a) Showing many nanowire bunches growing under nanoparticles. (b) Higher-resolution image of one nanowire bunch and one nanoparticle shown in (a). Branching growth can be observed. (c) One Chinese-lanternlike nanowire bunch grown under one nanoparticle. Both branching growth and coalescence are obvious. (d) Another Chinese-lanternlike nanowire structure. From its right side, a queue or ropelike nanowire bunch can be observed.

TEM results show that the black core is crystalline while the shell is amorphous as shown in Fig. 5(c). EDX measurements within the TEM apparatus show that the core contains Ni, Ga, Si, and O, and that their atomic percentages are 24, 44, 17, and 15, respectively, while the shell contains  $SiO_x$ with  $x \sim 0.3$ . Comparing these values with those obtained with EDX-equipped SEM, one can find that the atomic ratio of Ga to Ni is in rough agreement, but Si to O is not. This is likely because EDX performed in the SEM provides an average of composition over a larger number of nanostructures due to their higher density and larger area measured. Similar nanostructures showing amorphous SiOx shells and crystalline SiC (Refs. 8 and 15) or Si (Refs. 14 and 16) cores have also been reported. Nanowires without the core/shell structure but of amorphous SiO<sub>x</sub> are shown in Fig. 5(d). TEM examinations of the samples grown under other conditions also show that the SiO<sub>r</sub> nanowires are amorphous, in agreement with the literature.

In order to clarify the role played by Ni(NO<sub>3</sub>)<sub>2</sub>, Ga, and NH<sub>3</sub> in the formation of the SiO<sub>x</sub> nanowire bunches, another set of experiments were conducted using the conditions similar to condition I detailed in Table I, but leaving out one of the sources each time for comparison. The resulting morphologies of the samples are shown in Fig. 6. Figure 6(a) presents the result without depositing Ni(NO<sub>3</sub>)<sub>2</sub>\*6H<sub>2</sub>O to the substrate. From the figure, it is observed that single nanowires growing out of isolated particles are produced instead of the nanowire bunches. EDX measurements suggest that the nanoparticles contain O, Si, and Ga with the atomic per-

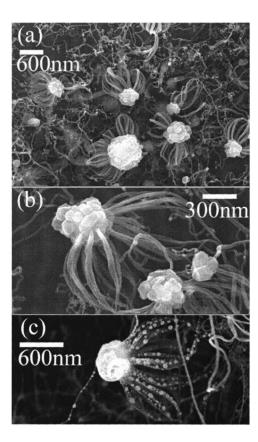


FIG. 4. Typical octopuslike nanowire bunches obtained with condition III. (a) Showing many octopuslike nanowire bunches. (b) Higher-resolution image of one bunch. It can be observed that the nanowires are not uniform in diameter. (c) Higher-resolution image of one octopus nanowire bunch with spotted nanowires.

centages of 7, 91, and 2, respectively, while the nanowires contain Si only. Obviously, Ga has catalyzed the growth of Si nanowire in this case. <sup>16</sup>

The result for growth without Ga is shown in Fig. 6(b). Particles 600 nm in size containing O, Si, and Ni with the atomic percentages of 11, 83, and 6, respectively, and separated Si nanowires are seen. It has been reported that Si nanowires can be grown by heating Ni-coated Si at 950 °C under Ar/H<sub>2</sub> flow. <sup>17</sup> Our results seem to agree with this assignment. Without NH<sub>3</sub>, octopuslike nanowire bunches together with randomly aligned nanowires are obtained, as shown in Fig. 6(c). The head of the octopuslike bunch contains Ni, Ga, Si, and O while the tail contains only Si and O, suggesting the catalyzing effect of Ni and Ga. The morphology is similar to those reported. <sup>5–7</sup>

Based on these results, it can be concluded that Ga and Ni(NO<sub>3</sub>)<sub>2</sub> are essential in the formation of the jellyfishlike SiO<sub>x</sub> nanowire bunches, while the NH<sub>3</sub> affects the bunch morphology. It has been reported that at 900 °C, Ni(NO<sub>3</sub>)<sub>2</sub> will decompose and NiO nanoparticles form. Above 930 °C, Ni reacts with Si forming Si<sub>2</sub>Ni eutectic alloy droplets. At 950 °C, on the other hand, GaSi<sub>x</sub> with x < 1% and NiSi<sub>y</sub> with y > 10% will form. This may explain the results of Figs. 6(a) and 6(b), where the nanowires grown with Ni(NO<sub>3</sub>)<sub>2</sub> only are much denser than that with Ga only, and the NiSiO particles are around 600 nm. It is Ni that plays the major role in etching Si to provide a Si source for SiO<sub>x</sub> nanowire bunch growth.

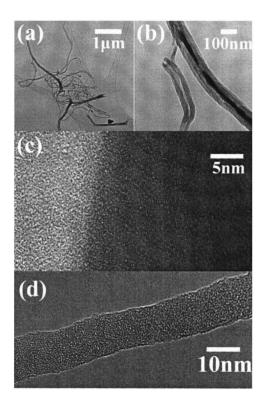


FIG. 5. TEM images of the materials grown with condition I. (a) Lower magnification images of the nanowires showing that some nanowires have a black core while others do not. (b) The core is not continuous inside the nanowires. (c) Higher-resolution images of the crystalline core and the amorphous shell in (b). (d) Higher-resolution image of one amorphous nanowire without a core.

 ${\rm SiO}_x$  nanowires can grow perpendicular to the surfaces of Ga balls. <sup>5,16,19</sup> Therefore, when the NiSiO particle surfaces are coated with Ga and when the liquid droplets get supersaturated with Si and O,  ${\rm SiO}_x$  nanowires will grow from the whole surface and  ${\rm SiO}_x$  nanowire bunches will form. Because the bonding of Si–O is stronger than that of Ga–O, only  ${\rm SiO}_x$  will precipitate. <sup>5</sup> Since the samples grown with only Ga or  ${\rm Ni(NO_3)_2}$  contain only Si nanowires, the possibility of atmosphere leakage of the tube, the abundance of residual oxygen in the tube, and the presence of an oxide layer on Si wafer or oxygen contained in Ar or  ${\rm NH_3}$  sources can all be ruled out as the source of oxygen for  ${\rm SiO}_x$  nanowire growth. Therefore, the relevant oxygen source in our system is the  ${\rm Ni(NO_3)_2}$  used in the experiment. At the presence of liquid Ga droplets, which strongly absorb  ${\rm O}_x$  the oxygen source may be efficiently maintained in the chamber.

Finally, it seems also that NH<sub>3</sub> has some effects on the nanowire bunch formation, as varying the gas ratio of Ar to NH<sub>3</sub>, the morphology will vary. However, further research is needed to elucidate the effects of NH<sub>3</sub> gas flow on the nanowire bunch morphology.

Though there are  $NH_3$ , Ga, and Ni in the system, and Ni can in principle catalyze<sup>18</sup> the growth of GaN nanowire, no GaN nanowire was actually obtained. The reason for this again needs further investigation. Notably,  $SiO_x$  nanowire formation was also observed during GaN nanowire fabrications by Wang *et al.*<sup>3</sup> and Zheng *et al.*<sup>19</sup>

Compared with other methods, this work suggests a convenient way of fabricating  $SiO_x$  nanowires at low tempera-

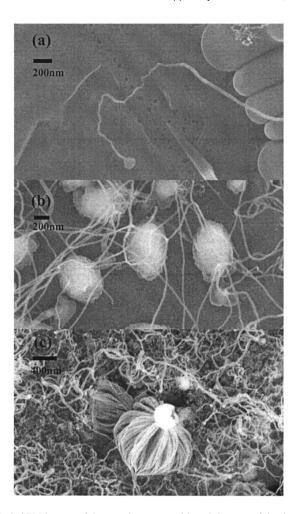


FIG. 6. SEM images of the samples grown with omitting one of the three—Ni(NO<sub>3</sub>)<sub>2</sub>, Ga, and NH<sub>3</sub>—while keeping other parameters the same with condition I. (a) SEM images of the materials grown without Ni(NO<sub>3</sub>)<sub>2</sub>. Ga catalyzing Si nanowire growth was clearly observed. (b) The materials grown without Ga. Si nanowires and particles containing Ni, Si, and O were observed. (c) The materials grown without NH<sub>3</sub>. Without NH<sub>3</sub>, the morphology is different, suggesting that NH<sub>3</sub> plays a role in the jellyfishlike nanowire bunch formation.

ture, short reaction time, and the easily available Si wafers as the Si sources. This is mainly attributed to the use of two elements as the catalysts. Indeed, combinations of two or more catalytic elements may improve nanowire growth and provide more flexibility for different morphologies of the nanowires.

#### IV. CONCLUSION

To conclude, amorphous  $SiO_x$  nanowire bunches have been grown in a tube furnace by employing Ga and Ni cocatalysts. The samples have been characterized by SEM, TEM, and EDX. Several different morphologies are observed depending on the growth conditions. It is found that Ga,  $Ni(NO_3)_2$ , and  $NH_3$  all play important roles in the formation of jellyfishlike nanowire bunches. The role of  $Ni(NO_3)_2$  is to etch Si from the substrate and to provide O for  $SiO_x$  nanowire growth. Besides trapping O from  $Ni(NO_3)_2$ , Ga will also catalyze the bunch growth of  $SiO_x$  nanowires.

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